## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of

Jun HATKAEYAMA et al.

Application No.: 10/797,201

Filed: March 11, 2004

Docket No.: 118988

For:

AN ANTI-REFLECTION FILM MATERIAL AND A SUBSTRATE HAVING AN ANTI-

REFLECTION FILM AND A METHOD FOR FORMING A PATTERN

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- $\boxtimes$ 2. Abstracts of the non-English language references cited in our March 11, 2004 Information Disclosure Statement are attached hereto.
- $\boxtimes$ Translations of the non-English language references cited in our March 11, 2004 Information Disclosure Statement are attached hereto. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-4.

Respectfully submitted,

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JAO:TJP/mlo

Date: April 14, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461 APR 1 4 2004

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INFORMATION DISCLOSURE STATEMENT												
(Use several sheets if necessary)			-	APPLICANT(S) Jun HATAKEYAMA et al.								
			-	FILING DATE March 11, 2004			GROUP					
U.S. PATENT DOCUMENTS												
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		DOCUMENT NUMBER	Ε	DATE		COUNTRY		CLASS	SUB CLASS			
	1.	JP B2 7-69611 w/transl. (only)	7/31/1995		JAPAN							
	2.	JP B2 3287119 w/transl. (only)	3/15	/2002	JAPAN							
<del>, , .</del> .	3.	JP B2 3118887 w/transl. (only)	10/1	3/2000	JAPAN							
	4.	JP A 5-27444 w/transl. (only)	2/5/1993		JAPAN							
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	1	OTHER DOCUMENTS (Inclu	uding	g Author,	Title, Date, Pe	rtinent Pag	es, etc.)					
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.												

Date: April 14, 2004